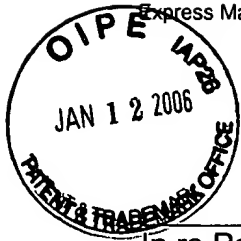


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15w 3723



Express Mail No. EV758926242US

Attorney Docket No. 108298515US1
Disclosure No. 00-0998.00/US

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Lee et al.

Application No.: 09/888,084

Confirmation No.: 8101

Filed: June 21, 2001

Art Unit: 3723

For: METHODS AND APPARATUS FOR
ELECTRICAL, MECHANICAL AND/OR
CHEMICAL REMOVAL OF CONDUCTIVE
MATERIAL FROM A
MICROELECTRONIC SUBSTRATE

Examiner: D. V. Nguyen

INFORMATION DISCLOSURE STATEMENT (IDS)

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is filed before the mailing date of a first Office Action after the filing of a Request for Continued Examination under 37 CFR 1.114 (37 CFR 1.97(b)(4)).

Copies of the references on the PTO/SB/08 are not provided.

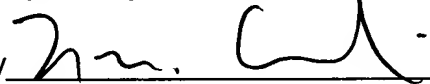
In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists. In accordance with 37 CFR 1.97(h), the filing of this Information Disclosure statement shall not be construed to be an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such.

It is submitted that the Information Disclosure Statement is in compliance with 37 CFR 1.98 and the Examiner is respectfully requested to consider the listed references.

The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 50-0665, under Order No. 108298515US1.

Dated: January 12, 2006

Respectfully submitted,

By 

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Disclosure No. 00-0998.00/USPTO/SB/08a/b (07-05)
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Substitute for form 1449A/B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Complete if Known	
				Application Number	09/888,084-Conf. #8101
				Filing Date	June 21, 2001
				First Named Inventor	Whonchee Lee
				Art Unit	3723
				Examiner Name	D. V. Nguyen
Sheet	1	of	1	Attorney Docket Number	108298515US1

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)	MM-DD-YYYY		
		US-2005/0178743-A1	08-18-2005	Manens et al.	
		US-6,848,970-B2	03-18-2004	Manens et al.	
		US-2005/0173260-A1	08-11-2005	Basol et al.	
		US-2005/0133379-A1	06-23-2005	Basol et al.	
		US-2004/0259479-A1	12-23-2004	Sevilla	
		US-6,893,328-B2	10-28-2004	So	
		US-6,852,630-B2	10-24-2002	Basol et al.	
		US-6,867,136-B2	06-26-2003	Basol et al.	

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)	MM-DD-YYYY			

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NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²

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¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.

Examiner Signature		Date Considered	
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